



1 inch C-plane n-type high-transparency AMMONO-GaN substrate.
The substrate is sliced from a mono-crystalline bulk material grown by ammonothermal method.

TECHNICAL SPECIFICATION

DESCRIPTION	UNIT	VALUE
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General specification

Orientation		(0001) C plane
Thickness	μm	350 (±100)
Dimension(s)	mm	Ø25,7 (±0,5)
Primary Flat (PF)	mm	12 (±1)
Secondary Flat (SF)	mm	8 (±1)
Bow	μm	≤ 10
Total Thickness Variation (TTV)	μm	≤ 40

Structural specification

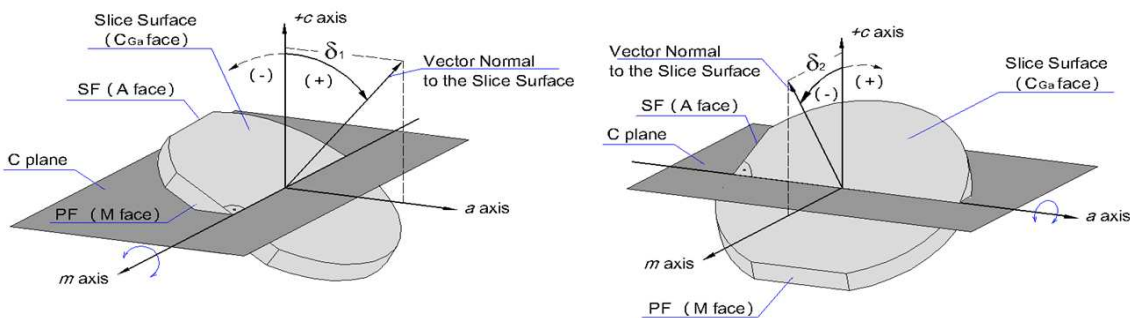
Etch Pit Density (EPD)	cm ⁻²	< 5 x 10 ⁴
FWHM of X-ray rocking curve, epi-ready surface at 100 μm x 100 μm slit	arcsec	~ 20
Macrodefects		none

Electrical specification

Conductivity		n type
Carrier concentration	cm ⁻³	2 x 10 ¹⁷ - 2 x 10 ¹⁸
Resistivity	Ω*cm	10 ⁻³ - 10 ⁻²
Mobility	cm ² /V*s	~ 150

MISORIENTATION

(measured in the center of the substrate)

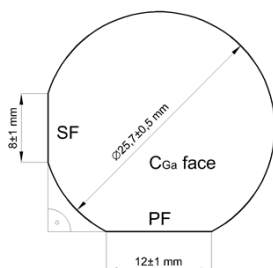


Off M face		deg	0 (±0,25)
C face	angle δ_1	deg	0 (±0,20)
	angle δ_2	deg	±0,3 (±0,20)

SURFACE PREPARATION

Front side		Epi-ready polished (RMS < 0,5 nm)
Back side		Roughly polished

SUBSTRATE SHAPE



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